

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

MICRON TECHNOLOGY, INC.
Petitioner

v.

PRESIDENT AND FELLOWS OF HARVARD COLLEGE
Patent Owner

Case IPR. No. IPR2017-00664
U.S. Patent No. 8,334,016

Title: VAPOR DEPOSITION OF METAL OXIDES, SILICATES AND
PHOSPHATES, AND SILICON DIOXIDE

**PETITIONER'S NOTICE OF DEPOSITION OF
WAYNE L. GLADFELTER, Ph.D.**

In accordance with 37 C.F.R. § 42.53, Micron Technology, Inc. (“Petitioner”) provides notice to President and Fellows of Harvard College (“Patent Owner”) that the deposition of Dr. Wayne Gladfelter will be held on January 11 and 12, 2017, commencing at 9:00am at the office of Pepper Hamilton LLP, 19th Floor, High Street Tower, 125 High Street, Boston MA, 02110-2736. The deposition will be recorded by stenographic means before an officer duly authorized by law to administer oaths under 35 U.S.C. § 23.

Pursuant to 37 C.F.R. § 42.53(d)(1), the parties have conferred and have agreed on these dates and location for the aforementioned deposition.

Respectfully submitted,

WEIL, GOTSHAL AND MANGES LLP

Dated: December 8, 2017

By:  _____

Jeremy Jason Lang
Lead Counsel for Petitioners
Registration No. 73,604
Weil, Gotshal & Manges LLP
201 Redwood Shores Parkway
Redwood Shores, CA 94065
Telephone: 650-802-3237

CERTIFICATE OF SERVICE

The undersigned certifies, in accordance with 37 C.F.R. § 42.105 and § 42.6(e), that service was made on the Patent Owner as detailed below.

<i>Date of service</i>	December 8, 2017
<i>Manner of service</i>	EXPRESS MAIL
<i>Documents served</i>	PETITIONER'S NOTICE OF DEPOSITION OF WAYNE L. GLADFELTER, Ph.D.
<i>Persons served</i>	<u>Patent Owner's Counsel of Record:</u> Reza Mollaaghababa Thomas Engellenner Andrew Schultz mollaaghababar@pepperlaw.com engellenner@pepperlaw.com schultza@pepperlaw.com BN_IPR-Harvard@pepperlaw.com Pepper Hamilton LLP 125 High Street 19th Floor, High Street Tower Boston, MA 02110-2736



Jeremy Jason Lang
Lead Counsel for Petitioner
Registration No. 73,604